

5/3/06

**INFORMATION DISCLOSURE
STATEMENT BY APPLICANT**
(Not for submission under 37 CFR 1.99)

Application Number		10729831
Filing Date		2003-12-05
First Named Inventor	En-Hsing Chen	
Art Unit	2827	
Examiner Name	Pham, Ly D.	
Attorney Docket Number	023-0028	

LP ↓	2	20030214835	A1	2003-11-20	Nejad et al.	
	3	20030227795	A1	2003-12-11	Seyyedy et al.	
	4	20040057276	A1	2004-03-25	Nejad et al.	
	5	20040125653	A1	2004-07-01	Tran et al.	

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EXAMINER SIGNATURE

Examiner Signature	/Ly Pham/	Date Considered	05/05/2006
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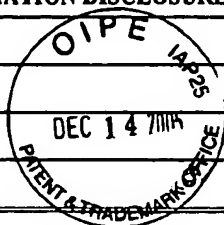
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LP ↓ ↓	1	6266275	B1	2001-07-24	Chen et al.	
	2	6845042	B2	2005-01-18	Ichige et al.	
	3	5734609		1998-03-31	Choi et al.	
	4	5909393		1999-06-01	Tran et al.	
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LP	1	20030095448	A1	2003-05-22	Ichige et al.	

PTO/SB/08A (Substitute for form 1449/PTO)		Attorney Docket No.: 023-0028
		Application No.: 10/729,831
INFORMATION DISCLOSURE STATEMENT BY APPLICANT		First Named Inventor: En-Hsing Chen, et al.
		Filing Date: December 5, 2003
		Group Art Unit: 2827
		Examiner Name: Pham, Ly D.
Sheet 1 of 1		Date Submitted: December 8, 2005



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LP	AE	US 2005/0121790	06-09-2005	Cleaves et al.		
LP	AF	US 2003/0109093	06-12-2003	Harari et al.		
LP	AG	US 2005/0018485 A1	01-27-2005	Noguchi et al.		
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LP	AN	WO-2002-43067 US	05-2002			Abstract Only
Examiner Signature		/Ly Pham/		Date Considered	09/15/2006	

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